

**Application Data Sheet**

**Applicant Information**

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Yasutsugu
Family Name::	SOETA
City of Residence::	Gunma
Country of Residence::	Japan

---

**Correspondence Information**

Correspondence Customer Number::	25944
----------------------------------	-------

**Application Information**

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None
Title::	POLISHING PAD, METHOD FOR PROCESSING POLISHING PAD AND METHOD FOR PRODUCING SUBSTRATE USING IT
Attorney Docket Number::	127462
Suggested Drawing Figure::	1
Total Drawing Sheets::	4
Small Entity::	No

**Representative Information**

James A. Oliff, Reg. No. 27,075	William P. Berridge, Reg. No. 30,024
Thomas J. Pardini, Reg. No. 30,411	Edward P. Walker, Reg. No. 31,450
Robert A. Miller, Reg. No. 32,771	Mario A. Costantino, Reg. No. 33,565
Kirk M. Hudson, Reg. No. 27,562	

<b>Domestic Priority Information</b>			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP2004/013661	September 17, 2006
<b>Foreign Priority Information</b>			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-335939	September 26, 2003	Yes
<b>Assignee Information</b>			
Assignee Name::		Shin-Etsu Handotai Co., Ltd.	
Street of mailing address::		4-2, Marunouchi 1-chome	
City of mailing address::		Chiyoda-ku	
State or Province of mailing address::		Tokyo	
Country of mailing address::		Japan	
Postal or Zip Code of mailing address::		100-0005	